
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Application Information**

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: METHOD OF PRODUCING PHASE SHIFT MASK
BLANK, METHOD OF PRODUCING PHASE
SHIFT MASK, PHASE SHIFT MASK BLANK, AND
PHASE SHIFT MASK
Attorney Docket Number:: 119162
Total Drawing Sheets:: 15
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Hiroki
Family Name:: YOSHIKAWA
City of Residence:: Niigata
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Yukio
Family Name:: INAZUKI
City of Residence:: Niigata
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan

Status::	Full Capacity
Given Name::	Noriyasu
Family Name::	FUKUSHIMA
City of Residence::	Niigata
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hideo
Family Name::	KANEKO
City of Residence::	Niigata
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Satoshi
Family Name::	OKAZAKI
City of Residence::	Niigata
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-093280	03/31/2003	Yes
Assignee Information			
Assignee Name::	Shin-Etsu Chemical Co., Ltd.		
Street of mailing address::	6-1, Otemachi 2-chome, Chiyoda-ku		
City of mailing address::	Tokyo		
Country of mailing address::	Japan		